

Sir:

Transmitted herewith for filing is the Patent Application of:

Inventor: **CHENG-KU CHEN, MIN-HWA CHI**

For: **METHOD OF FORMING POLYSILICON GATE STRUCTURES WITH SPECIFIC EDGE PROFILES FOR OPTIMIZATION OF LDD OFFSET SPACING**

Enclosed are:

- ☒ **5** sheets of drawing(s) - formal.
- ☒ An assignment of the invention to **Taiwan Semiconductor Manufacturing Co.**
- ☐ An associate power of attorney ☐ Applicant claims small entity status
- ☐ Request & Certification under 35 USC 122(b)(2)(b)(i)

The filing fee has been calculated as shown below:

	(Col. 1)	(Col. 2)	OTHER THAN A SMALL ENTITY	
FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 770.
TOTAL CLAIMS	27 -20=	7	x 18 =	\$ 126.
INDEP CLAIMS	2 -3=	0	x 86 =	\$ 0.
			SUB TOTAL	\$ 896.
			ASSIGNMENT	\$40.
			TOTAL	\$ 936.

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☒ Any additional filing fees required under 37 CFR §1.16.

☒ Any patent application processing fees under 37 CFR §1.17.

Respectfully submitted,

STEPHEN B. ACKERMAN, REG. NO. 37,761

EXPRESS MAIL CERTIFICATE

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I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450. Applicant and/or Attorney requests the date of deposit as the Filing Date.

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